

## PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1  
 Stylesheet Version v1.2

EPAS ID: PAT6480921

<b>SUBMISSION TYPE:</b>	NEW ASSIGNMENT	
<b>NATURE OF CONVEYANCE:</b>	ASSIGNMENT	
<b>CONVEYING PARTY DATA</b>		
	<b>Name</b>	<b>Execution Date</b>
	WEI-CHING WU	03/05/2012
	WEN-LONG LEE	03/05/2012
	DING-I LIU	03/05/2012
<b>RECEIVING PARTY DATA</b>		
<b>Name:</b>	TAIWAN SEMICONDUCTOR MANUFACTURING COMPANY, LTD.	
<b>Street Address:</b>	8, LI-HSIN RD. 6, HSINCHU SCIENCE PARK	
<b>City:</b>	HSINCHU	
<b>State/Country:</b>	TAIWAN	
<b>Postal Code:</b>	300-78	
<b>PROPERTY NUMBERS Total: 1</b>		
<b>Property Type</b>	<b>Number</b>	
<b>Application Number:</b>	17141974	
<b>CORRESPONDENCE DATA</b>		
<b>Fax Number:</b>	(703)518-5499	
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>		
<b>Phone:</b>	7036841111	
<b>Email:</b>	tsmc@ipfirm.com	
<b>Correspondent Name:</b>	HAUPTMAN HAM, LLP (TSMC)	
<b>Address Line 1:</b>	2318 MILL ROAD	
<b>Address Line 2:</b>	SUITE 1400	
<b>Address Line 4:</b>	ALEXANDRIA, VIRGINIA 22314	
<b>ATTORNEY DOCKET NUMBER:</b>	T5057-Y570B	
<b>NAME OF SUBMITTER:</b>	RANDY A. NORANBROCK	
<b>SIGNATURE:</b>	/Randy A. Noranbrock/	
<b>DATE SIGNED:</b>	01/05/2021	
<b>Total Attachments: 1</b>		
source=EfiledAssign#page1.tif		

2011-1046

Docket No. T5057-Y570

## ASSIGNMENT

In consideration of the premises and other good and valuable consideration in hand paid, the receipt and sufficiency of which is hereby acknowledged, the undersigned,

- 1) Wei-Ching WU
- 2) Wen-Long LEE
- 3) Ding-I LIU

who has made a certain new and useful invention, hereby sells, assigns and transfers unto

TAIWAN SEMICONDUCTOR MANUFACTURING COMPANY, LTD. having a place of business at No. 8, Li-Hsin Rd. VI, Hsinchu Science Park, Hsinchu 300, Taiwan R.O.C.

its successors and assigns (hereinafter designated "ASSIGNEE") the entire right, title and interest for the United States of America as defined in 35 U.S.C. 100 in the invention entitled

ADJUSTABLE NOZZLE FOR PLASMA DEPOSITION AND A METHOD OF CONTROLLING THE ADJUSTABLE NOZZLE

- (a) for which an application for United States Letters Patent was filed on 2011-12-16, and identified by United States Patent Application No. 13/328,474; or
- (b) for which an application for United States Letters Patent was executed on \_\_\_\_\_,

and the undersigned hereby authorizes and requests the United States Commissioner of Patents and Trademarks to issue any and all United States Letters Patent which may be granted therefore and any and all extensions, divisions, reissues, continuations, or continuations-in-part thereof, and the right to all benefits under the International Convention for the Protection of Industrial Property to the said ASSIGNEE, for its interest as ASSIGNEE, its successors, assigns and legal representatives; the undersigned agrees that the attorneys of record in said application shall hereafter act on behalf of said ASSIGNEE;

AND the undersigned hereby agrees to transfer a like interest, and to render all necessary assistance in making application for and obtaining original, divisional, reissued or extended Letters Patent of the United States, upon request of the said ASSIGNEE, its successors, assigns and legal representatives, and without further remuneration, in and to any improvements, and applications for patent based thereon, growing out of or related to the said invention; and to execute any papers by the said ASSIGNEE, its successors, assigns and legal representatives, deemed essential to ASSIGNEE's full protection and title in and to the invention hereby transferred.

SIGNED on the date indicated aside my signature:

- 1) Wei-Ching Wu  
Name: Wei-Ching WU
- 2) Wen-Long Lee  
Name: Wen-Long LEE
- 3) Ding-I Liu  
Name: Ding-I LIU

2012/03/05  
Date:

2012/3/5  
Date:

2012/03/05  
Date: